

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination IDO ET AL.	
		10/588,312	Examiner	Art Unit Michael Mapa 2617

**U.S. PATENT DOCUMENTS**

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*	A US-2005/0113115	05-2005	Haberman et al.	455/456.3
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**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U Provisional application 60516351 Specification of Haberman et al. (US Patent Publication 2005/0113115)
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))  
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